

## Contribution submission to the conference Berlin 2024

**Bare and Pd-doped ceria thin films prepared by ALD and EBE for hydrogen detection** — •YULIIA KOSTO<sup>1</sup>, PAULINA KAPUSCIK<sup>2</sup>, RUDI TSCHAMMER<sup>1</sup>, DOMINIC GUTTMANN<sup>1</sup>, EWA MANKOWSKA<sup>2</sup>, PETER MATVIJA<sup>3</sup>, CARLOS MORALES<sup>1</sup>, MICHAL MAZUR<sup>2</sup>, KARSTEN HENKEL<sup>1</sup>, IVA MATOLINOVA<sup>3</sup>, JAROSLAW DOMARADZKI<sup>2</sup>, and JAN INGO FLEGE<sup>1</sup> — <sup>1</sup>BTU Cottbus-Senftenberg, Appl Phys & Semicond Spect, Cottbus, Germany — <sup>2</sup>Wroclaw Univ Sci & Technol, Fac Elect Photon & Microsyst, Wroclaw, Poland — <sup>3</sup>Charles Univ, Dept Surface & Plasma Sci, Prague, Czech

The need to store and use hydrogen safely as part of green economy based on renewable energy evokes a necessity to reliably detect it at ambient conditions. The majority of currently used sensors are working at elevated temperatures (200-500 °C). In this work, we demonstrate that ceria films deposited on a commercial electrode by atomic layer deposition (ALD) and electron beam evaporation (EBE) electrically respond to hydrogen (from 20 to 500 ppm) at much lower temperatures (50-200 °C). The results reveal that <1.5 nm thin Pd adlayer increases the electrical response by several orders of magnitude for both ceria films. The NAP-XPS study under changing oxidative/reductive atmospheres sheds light on the mechanism of Pd-CeOx thermal activation and the role of the deposition technique in the reactivity of the oxide.

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